Schottky barrier heights at polar m etal/sem iconductor interfaces

C. Berthod

DPMC, Universite de Geneve, 24 quai Ernest-Anserm et, CH {1211 Geneve 4, Switzerland

N . Binggeli

International Center for Theoretical Physics (ICTP) and INFM DEMOCRITOS National Center, Strada Costiera 11, I{34014 Trieste, Italy

A. Baldereschi

Institut Rom and de Recherche Num erique en Physique des Materiaux (IRRMA), CH {1015 Lausanne, Switzerland (Dated: April 14, 2024)

U sing a rst-principle pseudopotential approach, we have investigated the Schottky barrier heights of abrupt A 1/G e, A 1/G aAs, A 1/A 1As, and A 1/ZnSe (100) junctions, and their dependence on the sem iconductor chem ical composition and surface term ination. A model based on linear-response theory is developed, which provides a simple, yet accurate description of the barrier-height variations with the chemical composition of the sem iconductor. The larger barrier values found for the anion-than for the cation-term inated surfaces are explained in terms of the screened charge of the polar sem iconductor surface and its image charge at the metal surface. A tom ic scale computations show how the classical image charge concept, valid for charges placed at large distances from the metal, extends to distances shorter than the decay length of the metal-induced-gap states.

PACS num bers: 73.30.+ y, 73.40 N s

I. INTRODUCTION

M etal/sem iconductor (M S) interfaces have been the focus of extensive theoretical and experimental studies for several decades. To date, however, we are still far from a complete understanding of the factors which control the Schottky barrier height (SBH) at these interfaces. In recent years, new research activities have been developed in the area of band engineering at M S interfaces for formal and on the properties of metal/widegap-sem iconductor contacts. These developments have stimulated renewed interest in some basic issues concerning Schottky barriers, and in particular in the mechanisms that control the SBH dependence on bulk-sem iconductor and interface-species concernistics.

The problem of Schottky barrier form ation has been traditionally addressed by studying the dependence of the SBH on the metalused in the junction. 14 Early studies suggested a Schottky-M ott behavior controlled by the m etalwork function for highly ionic orwide-gap sem iconductors, and a weak dependence on the metal type and on the junction fabrication method for the most covalent sem iconductors, such as Sior GaAs. 14 The latter trend was generally attributed to various Fermilevelpinning m echanism s, such as pinning by m etal-induced-gap states (M IGS)¹⁵ at an intrinsic charge neutrality level of the sem iconductor 16,17 or pinning by native defect states of the sem iconductor at som e extrinsic gap level. 18,19 Furthermore, a correlation between Schottky barriers and heterojunction band o sets was observed experim entally for a number of system s, 20 and similarly ascribed to Ferm i level pinning at a bulk reference level. Finally, the e ect of the sem iconductor ionicity on the SBH trend with the metalwork function was examined in pioneering

self-consistent studies of jellium /sem iconductor contacts, and the trend could also be generally understood in term s of M $\,$ IG $\,$ S properties of the sem iconductor. 21

M ore recent experim ents on m etal contacts to covalent sem iconductors, however, have revealed a much weaker electronic pinning than was previously believed. In particular, there have been reports of considerable changes in metal/Si and metal/GaAs SBH's obtained by altering the structural properties and/or the chemical composition of the interface. The conclusion that the SBH does depend most generally on the microscopic atom ic structure of the interface has been reached by m any authors, both on experim ental 2,3,5,6,7,8,11,12,22 and theoretical 11,23,24,25,26,27,28 grounds. While opening a promising line of research on Schottky barrier engineering, these observations complicate seriously the search for simple models of Schottky barrier formation, since the inclusion of the interface atom ic structure seem sunavoidable.

Given the complexity and variety of the atomic structure at metal/sem iconductor contacts, it seems unlikely that a simple unied model could emerge and entirely cover the various facets of Schottky barrier formation. Conversely, a systematic investigation of the problem starting from abrupt, defect free interfaces, and progressively introducing perturbations at the interface could help identifying relevant microscopic mechanisms and provide a rmerbasis formodeling Schottky barrier properties. Progress in computational physics have made possible accurate ab initio calculations of the electronic structure of MS contacts, and the complexity of the systems which can be examined is steadily increasing; this type of computations can provide the means to carry out such an investigation and probe the correlation between

m icroscopic atom ic structures and SBH's. The present study is a rst step in this direction.

In this article, we study from rst principles the dependence of the SBH on selected bulk and surface characteristics of the sem iconductor, for a given metal. Speci cally, we exam ine abrupt Al/X (100) junctions, where X = (Ge, GaAs, AlAs, and ZnSe) are lattice matched sem iconductors of increasing ionicity, and we investigate the microscopic mechanisms responsible for the SBH changes with the sem iconductor chemical composition and surface term ination (cation or anion). A model based on a linear-response-theory scheme is then developed, which explains our ab initio results and SBH trends observed experimentally.

II. METHOD OF CALCULATION

We have carried out ab initio calculations, within the Local-D ensity Approximation (LDA) to Density FunctionalTheory (DFT), using the pseudopotential method. 29 We used norm-conserving scalar-relativistic Troullier-Martins pseudopotentials in the Kleinman-Bylander non-local form 32 and the exchange-correlation functional of Ceperley and Alder.33 The electronic states were expanded on a plane-wave basis set using a kinetic energy cut-o of 20 Ry. We used supercells containing 7 Allayers and 13 sem iconductor layers (7 + 13 supercell) to model defect-free A 1/X (100) junctions. In section IV B, we em ployed larger supercells (7+21) to investigate the screening of substitutional charges placed in the junctions, and to compute the parameters (D $_{\rm s}$; $_{\rm s}$) necessary to model this screening. All supercell calculations were performed with a (2,6,6) M onkhorst-Pack k-point grid.34

We considered ideally abrupt epitaxial junctions and neglected atom ic relaxation at the interfaces. The effect of atom ic relaxation at the Al/GaAs (100) and Al/ZnSe (100) interfaces has been examined in Refs. 11 and 35. Atom ic relaxation decreases (increases) the p-

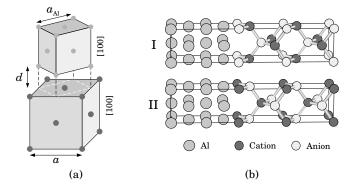


FIG. 1: (a) Epitaxial alignment of Alon the (100) surface of zinc-blende sem iconductors verifying the lattice-m atching condition $a_{A\,l}=a=\frac{1}{2}$. (b) Atom ic structure of the abrupt Al/sem iconductor (100) interface. The sem iconductor surface is term inated either by an anion (I) or a cation (II) plane.

type Schottky barriers of the abrupt A 1/G aA s (A 1/ZnSe) junctions by $0\{0.1 \text{ eV}^{35} \ (0.1\{0.2 \text{ eV}^{11,36}), \text{ and has no inuence on the SBH ordering of the anionuand cationterm inated interfaces.}$

The epitaxial alignment of Alon the (100) surfaces of the four sem iconductors under study is illustrated in Fig. 1(a). This type of alignment corresponds to the lattice-m atching condition: $a_{A1} = a^{-1} \overline{2}$, where a is the sem iconductor lattice param eter. The Al [100] direction is parallel to the sem iconductor [100] axis, and the whole Alfoc lattice is rotated by 45 about its [100] axis with respect to the sem iconductor substrate. Experim entally and also in our calculations | Ge, GaAs, AlAs, and ZnSe are lattice-m atched sem iconductors, and the equilibrium lattice constant of Alis slightly larger (1%) than a= 2. This results in a small compressive strain in the Al in-plane lattice parameter, which is accommodated by an elongation (3%) of the Aloverlayer, assuming pseudom orphic conditions. For the sem iconductor lattice param eter, we used the theoretical value a = 5:55 A (a^{exp.} = 5:65 A). The metal-sem iconductor interlayer distance d at the junction was taken as the average between the (100) interlayer spacings in the sem iconductor and in the (strained) Albulk parts, i.e., d = 1:72 A. The polar A 1/X (100) junction o ers two inequivalent abrupt interfaces, either with anion-or cation-term inated sem iconductor surface, which we both considered in our study [see Fig. 1 (b)]. In what follows, we will refer to the anionand to the cation-term inated interface as interface I and II, respectively.

To evaluate the p-type SBH, p, we used the same approach as in previous studies 26,35

$$p = V + E_p; (1)$$

where V is the electrostatic-potential lineup at the interface and E $_{\rm p}$ is the dierence between the Ferm i level in the metal and the valence-band maximum (VBM) in the sem iconductor, each measured with respect to the average electrostatic potential in the corresponding crystal. The band-structure term E $_{\rm p}$ is characteristic of the individual bulk crystals forming the junction. This term was computed using the Kohn-Sham (KS) eigenvalues of standard bulk band-structure calculations. The potential lineup V contains all interface-specic contributions to $_{\rm p}$ and was obtained | via Poisson's equation and using a macroscopic average technique 26,35 | from the self-consistent supercell charge density.

For a meaningful comparison of our calculated SBH's with experiment, E_p should include quasiparticle and spin-orbit corrections. The spin-orbit correction is simply $+\frac{s_0}{3}$, where so is the total spin-orbit splitting at the sem iconductor valence-band maximum, which was taken from experiment. For a metal, in principle, the exact KS Ferm i energy and the quasiparticle Ferm i energy must coincide at zero temperature. Furthermore, LDA calculations for the work functions of various Al surfaces performed with the same method and the same pseudopotentials as in the present study and neglecting

m any-body corrections on the A lFerm ienergy \mid yielded values which agree with the experimental data to within a few tenths of meV $.^{38}$ In the present study, therefore, for the metalFerm ienergy we just used the LDA result. The corrected band term is thus E $_p = E_p^{KS} E_{qp} - \frac{s_0}{3}$, where E $_p^{KS}$ is the KS band term and E $_{qp}$ is the difference between the quasiparticle and KS sem iconductor VBM energies.

For the quasiparticle corrections, we used the results of GW calculations taken from the literature. For A 1/G aAs

we used the correction $E_{qp}^{GaAs} =$ 0:36 eV evaluated by Charlesworth et al., 25 who employed for the reference LDA calculations the same exchange-correlation potential as we do. For Ge (A IAs) we used the correction for GaAs, and the di erence between the Ge (A IAs) and GaAs corrections evaluated in Ref. 39, ie., $E_{qp}^{GaAs} = +0.09 \text{ eV} \text{ (} E_{qp}^{AlAs}$ 0:11 eV).40 The quasiparticle corrections to the band structure of ZnSe have been evaluated in Ref. 41. As the LDA bandgap in our calculations and in Ref. 41 are di erent, due to the di erent pseudopotentials em ployed, we took the valence-band-edge correction of Ref. 41 and scaled it by the ratio of the dierence between the LDA and GW bandgap in the two calculations. The resulting estim ate for $~E_{\rm qp}^{\rm \,ZnSe}$ is ~0.50~eV .U sing the experim ental spin-orbit splittings $\frac{X}{50} = 0.30, 0.34, 0.28, \text{ and } 0.43 \text{ eV}$ for X = Ge, GaAs, AIAs, and ZnSe, AIAs the total corrections are 0.17, 0.25, 0.36, and 0.36 eV, respectively.43 The num erical uncertainty on the absolute value of the SBH's is estimated as 0:1 eV for Al/Ge, Al/GaAs, and A 1/A 1As, and as 02 eV for A 1/ZnSe. For a given inter-

III. RESULTS FOR THE SCHOTTKY BARRIER HEIGHTS

face geom etry, however, the relative barrier values (p

in Table II) are considerably more accurate, i.e., have an

estim ated num erical accuracy of 50 m eV.

The calculated SBH's for the abrupt A 1/X (100) interfaces, including many-body and spin-orbit corrections, are given in Table I. We observe a systematic di erence between the type-I and type-II interfaces: the p-type SBH is always higher for the type-I (anion-term inated) interface. This di erence increases with increasing sem iconductor ionicity. Our theoretical results are compared with experimental SBH values in Fig. 2. For the Al/Ge, A 1/G aAs, and A 1/A 1As systems the experimental ranges correspond to data obtained by transport m easurem ents. In the case of A 1/G aAs, photoem ission measurements perform ed at low m etal coverage give rise to a wider range of SBH values, 44 but the scattering in the data decreases signi cantly when thick metallic overlayers are deposited and the barriers are measured by transport techniques. For A 1/ZnSe we are not aware of any transport data and we used photoem ission results.

In the case of A 1/G e, no SBH m easurem ent has been performed, to our knowledge, on the (100)-oriented inter-

TABLE I: Estimated quasiparticle and spin-orbit corrections to $_{\rm p}^{\rm LD\,A}$ for dierent semiconductors. The calculated A 1/X (100) SBH's including these corrections are shown in the last two columns. All numbers are in eV .

Sem iconductor	Estimated		p
X	correction	I	II
Ge	0.17	0.2	21
G aA s	0.25	0.86	0.76
AlAs	0.36	1.45	1.16
ZnSe	0.36	2.18	1.82

face. In Fig. 2 we have thus used the existing transport data⁴⁵ on A 1/n-Ge (111) junctions ($_n$ = 0:52{0.61 eV), together with the Ge experim ental bandgap at room tem perature, $E_{\alpha}^{Ge} = 0:66 \text{ eV}$. The resulting barrier heights $_{p} = 0.05\{0.14 \text{ eV com pare reasonably wellwith our cal-}$ culated value of 0.21 eV . In the case of A 1/G aAs (100) the transport m easurem ents give values of $_{\rm p}$ between 0.58 eV and 0.76 eV 8,9,10,47,48,49,50,51,52,53,54,55,56 (we used $E_{\sigma}^{G \text{ aAs}} = 1:42 \text{ eV}$ to estimate the p-type barrier heights from measurements performed on Al/n-GaAs junctions). This is in relatively good agreement with our calculated SBH of 0.76 eV for the Ga-term in ated interface, and still consistent with our value of 0.86 eV for the Asterm inated interface. Concerning the e ect of the GaAs-surface stoichiom etry on the measured SBH, we note that di erent conclusions have been reached by di erent groups. Som e studies, including Refs. 48 and 49, have found a small (0:1 eV) di erence between the SBH's measured in junctions fabricated on As-rich and on Ga-rich surfaces (As-rich leading to higher p, consistent with our results), while other studies, such as Refs. 50 and 53, found no di erence.

For the A L/A LAs system, Ref. 49 reports SBH values for Alln-Alas (100) ranging from 0.85 to 0.94 eV for various reconstructions of the sem iconductor surface, while som ew hat higher values, 0.95 and 1.01 eV, have been given in Refs. 55 and 56, respectively. Using the experim ental bandgap E $_{g}^{\text{A IA s}}$ = 2:16 eV , the resulting range is $p = 1.15\{1.31 \text{ eV}$, in good agreem ent with the calculated SBH for the Alterm inated AlAs surface (1.16 eV), and somewhat smaller than the value we nd for the As-term inated surface (1.45 eV). The Al/n-ZnSe (100) SBH has been investigated in Refs. 11, 12, and 57 for di erent reconstructions of the ZnSe (100) surface. Very sim ilar values have been reported for the c(2 2) and 2 1 reconstructions, namely $_p = 2:12\{2.15 \text{ eV}^{11,12,57}$ and $p = 2.11\{2.15 \text{ eV}, \frac{11}{12} \text{ respectively, while a lower}$ SBH, $_{\rm p}$ = 1:91 eV, has been measured for the 1 $_{\rm 1}$ reconstruction. 11 These values are in between our values of 1.82 eV for the Zn-term inated and of 2.18 eV for the Se-term inated interface.

The general agreem ent between theory and experim ent in Fig. 2 indicates that our calculations for ideal MS structures (abrupt interfaces with no atom ic relaxation)

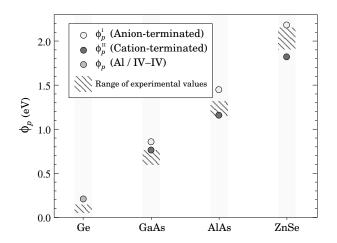


FIG. 2: Schottky barrier heights (SBH's) at A 1/X (100) contacts, X = Ge, Ge,

capture the general trend of the SBH with the chemical composition of the semiconductor. We note that for A 1/2 nSe, the inclusion of the appropriate reconstruction and relaxation brings the theoretical results in very close agreement with the experimental values. ¹¹

IV. INTERPRETATION AND MODELS

${\tt A}$. General trend with the sem iconductor chem ical composition

Experim entally a correlation was found between Schottky barriers and heterojunction band o sets. A large number of M S contacts and sem iconductor heterojunctions were shown to verify, within 0.4 eV, the transitivity relationship:

$$_{p} M = S_{1}$$
 $_{p} M = S_{2}$ = $E_{VBO} [S_{1} = S_{2}];$ (2)

where M is a metal (such as Alor Au; in general neither a highly reactive nor a transition metal 58), S_1 and S_2 are two semiconductors, and E_{VBO} [S_1 = S_2] is the corresponding valence-band o set (VBO). This correlation was most offen observed for MS junctions used in transport measurements, i.e., which had been annealed for fabrication of the contacts. The experimental data in Fig. 2 are in general agreement with the above empirical transitivity rule.

We note that the transitivity rule, as formulated in Eq. (2), disregards any dependence of the SBH on them i-croscopic interface structure, and cannot therefore give a complete account of the theoretical results in Fig. 2. Also, recent theoretical and experimental studies have shown that the band o set at heterovalent semiconductor heterojunctions depends critically on the orientation

and other m icroscopic details of the interface. ^{59,60,61} The right-hand side of Eq. (2) is thus ill de ned, in general, for heterovalent sem iconductors.

In this section we concentrate on the average SBH $_p=\frac{1}{2}\quad_p^I+\stackrel{II}{p}$ of the abrupt, defect-free type-I and II interfaces, and propose a model for its variation with the sem iconductor chemical composition, derived from an atom ic-scale approach. We show that this variation is controlled essentially by the same bulk mechanism that determines band o sets at non-polar, defect-free sem iconductor heterojunctions. The splitting $_p=\frac{I}{p}\quad_p^{II}$ due to the semiconductor-surface termination will be the focus of the next section.

Sim ilarly to the SBH, the VBO may be written as: $E_{VBO} = E_v + V$, where E_v is the dierence between the VBM energies of the two sem iconductors, each measured relative to the mean electrostatic potential in the corresponding crystal, and V is the electrostatic potential lineup at the interface. Since the band-structure terms E_v and E_p [in Eq. (1)] are dierences between bulk values of the individual crystals forming the junction, they verify by denition the transitivity relationship in Eq. (2). All non transitive contributions are contained thus in the potential lineup terms V.

In the case of sem iconductor heterojunctions a linear-response-theory (LRT) approach, which focuses on V and treats the interface as a perturbation with respect to a bulk reference system, has provided an accurate general description of band-o set trends. Based on this approach and comparision with fully self-consistent ab initio calculations, it has been shown, in particular, that in the case of defect-free, isovalent lattice-matched sem iconductor heterojunctions, V is determined by the properties of the bulk constituents (as opposed to interface special features, such as interface orientation or interface abruptness). Specially, if S_1 and S_2 are the two semi-conductors, with anion (cation) species S_1 (S_2) in S_2 , the potential lineup is given within LRT by:

$$V [S_1=S_2] = \frac{2 e^2}{3}^{Z} r^2 [n_a(r) + n_c(r)] dr;$$
 (3)

where the integration is over the whole space, is the volum e of the bulk unit cell, and n_a (n_c) is the electronic charge density induced by a single anion (cation) substitution a_1 ! a_2 (c_1 ! c_2) in the bulk sem iconductor S_1 . 62 B ased on this LRT approach, it has also been shown that in the case of heterovalent lattice m atched sem iconductors, Eq. (3) also applies in the specience case of defect-free interfaces with the non-polar (110) orientation. 60

Using a similar linear-response scheme for V, we show in Appendix A that the average SBH $_p$ can be described by the following model:

$$_{p}^{m \text{ od}} = _{p} \text{ [A } = hX \text{ i (100)]} + _{E_{VBO}} \text{ [hX } i = X \text{ (110)]} : (4)$$

The rst term on the right-hand side of Eq. (4) is the SBH at the (100) interface between Aland the group-IV

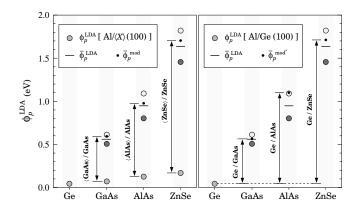


FIG. 3: Comparison of the average SBH $_{\rm p}^{\rm LDA}$ at the A l/X (100) I and II interfaces with the model predictions, Eq. (4) (left panel) Eq. (5) (right panel)]. The horizontal bar shows the average SBH and the small dot indicates the model result, i.e., the sum of the SBH at the A l/hX i (100) A l/Ge (100)] junction (gray circles [dashed line]) and the VBO at the hX i=X (110) [Ge/X (110)] interface (double arrows). The quasiparticle and spin-orbit corrections are not included; these contributions trivially verify Eqs. (4) and (5).

virtual crystal, denoted hX i, which is obtained by averaging the anion and cation pseudopotentials of the III-V or II-VI compound X (X = GaAs, AlAs, ZnSe). The second term is the VBO of the non-polar hX i/X (110) heterojunction.

The basic approximation to derive Eq. (4) is to construct the charge densities of the A 1/X I and II junctions (and hence their average lineup) starting from the reference A 1/hX i system, by adding a linear superposition of the charge densities induced in the virtual crystal hX i by single anion and cation substitutions that transform hX i into X. The A 1/hX i (100) junction is an optimal reference system in this context, which minimizes the deviations of p from p od in Eq. (4); these deviations vanish to the rst order in the ionic substitutions which transform A 1/hX i into the A 1/X I and II junctions.

It is also possible to use as a reference system another A 1/group-IV (100) junction, whose density is su ciently close to the average density of the A 1/X I and II junctions. For instance, one may use A 1/G e as a common reference system and obtain (Appendix A):

$$_{p}^{m \text{ od}^{0}} = _{p} \text{ [A } \text{1=Ge (100)]} + _{U \text{ BO}} \text{ [G } \text{e=X (110)]} \text{: (5)}$$

The deviations of $_p$ from $_p^{m \text{ od}^0}$ in Eq. (5) include, in this case, a rst order correction in the substitutions. The latter correction can be identified with the dipole induced in the reference A l/G e (100) junction by isovalent Ge! hX is substitutions performed within the rst one to three Ge atom ic layers closest to the interface (see Appendix A); such a dipolar term is generally small for isovalent substitutions (0:1 eV or less, see Ref. 28), and will be neglected here.

In Fig. 3 we compare graphically the model predictions, Eq. (4) and Eq. (5), with the calculated average

SBH of the A 1/X I and II interfaces. The (110) VBO's have been computed using supercells containing 8 planes of each semiconductor in the ideal (unrelaxed) latticem atched geom etry. The same energy cuto sand k-points grids have been used as in the calculations of the Schottky barriers. The SBH of the Al/hX i (100) junctions have been obtained using the sam e param eters as for the Al/X (100) I and II interfaces. The results in Fig. 3 show that Eq. (4) and Eq. (5) provide a fairly accurate (0:15 eV) description of the average SBH p. We note that the SBH 's at the A 1/hX i junctions are all sm all, due to the small bandgaps of the virtual crystals (< 0:4 eV), and sim ilar to the LDA SBH at the Al/Ge (100) interface (0.04 eV). The results in Fig. 3 show that the (110) VBO a bulk-related quantity in our calculations | controls the general increase of the barriers from the group-IV to the III-V and to the II-V I sem iconductors.

B. E ect of surface term ination

We will show here that the dierence $p = \begin{bmatrix} I & II \\ p & II \end{bmatrix}$ due to the sem iconductor-surface term ination in Fig. 2 $\begin{bmatrix} II & III \\ III & IIII \end{bmatrix}$ and in particular the fact that the SBH is system atically higher for the anion than for the cation term ination $\begin{bmatrix} III & IIII \\ IIII & IIIIIIII \end{bmatrix}$ can be understood in terms of surface-charge and in agecharge exts. The mechanism is illustrated in Fig. 4.

W ith respect to the A l/hX i interface, the ionic charge distributions of the interfaces I and II are obtained by

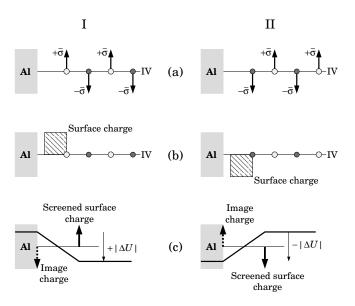


FIG. 4: (a) P lanar average of the di erence between the ionic charge densities of the anion- (cation-)term inated A 1/X (100) interface and the A 1/X (100) interface; = 1 for the sem i-conductors X = G aA s, A 1/X s, and = 2 for X = Z nSe. (b) M acroscopic average of the ionic charge density di erence. (c) P ositive (negative) potential di erence established at the interface I (II) by a positive (negative) surface charge and its im age charge at the m etal surface.

substituting an anion (charge +) on each anionic site and a cation (charge) on each cationic site, as indicated in Fig. 4(a). For the III-V and II-VI compounds = 1 and= 2, respectively, in units of we have charge per unit-cell surface in the (100) plane. The arrows in Fig. 4(a) represent opposite delta functions on each anionic and cationic (100) plane, corresponding to the planar average of the ionic point-charge density. The m acroscopic average^{59,60} of this ionic charge distribution is represented in Fig. 4(b). In the bulk sem iconductor, the macroscopic average eliminates the atomic-scale oscillations of the planar charge density; at the interface, however, a positive (negative) charge density subsists in the junction I (II). This macroscopic charge has a den-2 =a and extends over a distance a=4 between the last Alplane and the rst sem iconductor plane. It is therefore equivalent to a surface charge of density =2.

W ithin a classical macroscopic description, a plane of charge in a semiconductor is screened by the dielectric constant $_1$ of the host material. Furthermore, in the presence of a metal the screened surface charge is neutralized by an image charge induced at the metal surface, and a potential dierence is thus established between the two charges [see Fig. 4 (c)]. If is the density of surface charge in the semiconductor, x the position of the plane of surface charge, and x_i the position of the metal surface or image charge, the potential dierence obtained from classical electrostatics is:

U (x;) =
$$4 e^2 - (x x_i)$$
: (6)

As can be seen from Fig. 4(c), in the junction I such a dipole lowers the average potential energy in the semiconductor with respect to its value in the metal, increasing the SBH $_{\rm p}$; conversely, in the junction II the dipole raises the average potential in the semiconductor, decreasing $_{\rm p}$. The mechanism illustrated in Fig. 4 thus provides a qualitative explanation for the dierence between the SBH's of the interfaces I and II. Of course, the classical limit given by Eq. (6) is expected to be correct only for a charge placed at a large distance from the metal. As we will see below, however, closer to the metal the above type of description may still be used provided the inhom ogeneous nature of the screening near the metal is taken into account.

To check that the mechanism in Fig. 4 can indeed account for the SBH di erences $_{\rm p}$, we have calculated the changes in the lineup (and hence in the SBH) induced by surface charges of varying magnitude, placed on the sem iconductor plane closest to the metal in the A l/X I and II junctions. At the interface I (II), a surface charge of density $\,$ j j (+ j j) was introduced by replacing the anion A (cation C) of the sem iconductor layer adjacent to the metal surface by a virtual ion hA $_1$ $_2$ C $_2$ i (hC $_1$ $_2$ A $_2$ i). The resulting changes U in the SBH obtained from the ab initio calculations are shown in Fig. 5. The negative (positive) surface charge decreases (in-

creases) the p-type SBH of the anion-term inated (cation-term inated) interfaces, consistent with the screened surface charge and in age charge description in Fig. 4 (c). We also note that, consistent with the latter description, the bare monopole is replaced by an interface dipole in the multipole expansion of the total (electronic plus ionic) charge disturbance.

The macroscopic average of the dierence between the ionic potentials in the junctions II and I, in Fig. 4(a), is equivalent to a surface charge = 1 at the interface for the III-V sem iconductors and = 2 for the II-VI sem iconductors. Therefore, focusing on the e ect of the macroscopic charges only and to the storder in the perturbation, the modi cation of the SBH in the junctions I for = 1 (2) should be equal to the di erence $_{\rm p}^{\rm I}$ for the III-V (II-V I) sem iconductors. Sim ilarly, the change of the SBH in the junctions II induced by a surface charge = +1 (+2) should be equal to $\frac{1}{p}$ Our ab initio results in Fig. 5 show, however, that the responses U of the two interfaces are not linear when j j& 0:5 and di er in magnitude. Therefore, we take the average U between the potential di erences induced in the junctions I and II as our estimate for the dierence $_{\rm p}$. The results are shown in Table II. For A $1\!/\!\,{\rm ZnSe}$ we reported the calculated SBH changes for = 2 (not shown in Fig. 5). The average values U are seen to describe well the calculated dierence p and also the inp when the sem iconductor ionicity increases. crease of

A lthough this supports the surface charge and in age charge picture in Fig. 4(c), Eq. (6) needs to be revisited for charges placed close to the metal surface. For example, in the case of a test charge $\,=\,0:\!1$ on the $\,$ rst sem iconductor layer, we obtain from Eq. (6) a potential di erence U = 82 meV, using for the distance x $\,$ x $_i$ the value d=2, where d = 1:72 A is the interplanar distance at the interface (see Fig. 1), and for $_1$ the theoretical dielectric constant of G aA s, $_1^{\rm G\,aA\,s}=12:\!4:\!^{26}$ This result is more than 5 times larger than the ab initio result for

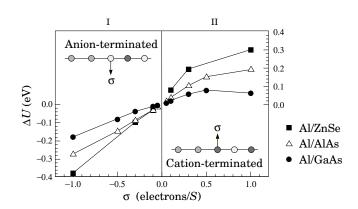


FIG.5: Schottky barrier modi cation U induced by a bare surface charge per unit-cell surface $S=a^2=2$ on the rst sem iconductor layer closest to the metal in the A l/X (100) I and II junctions (see insets; the same symbols for the atom ic layers are used as in Fig.1).

TABLE II: Comparison of the average SBH change \overline{U} induced by surface charges = 1 (G aAs, AlAs) and = 2 (ZnSe) at the interface, with the dierence $_p = _p^{\rm II}$ between the SBH of the anion—and cation—term inated Al/X (100) junctions (see text). The last column shows the results of the model Eq. (11). All energies are in eV.

Х	р	jυj		U	D s	s	m od p
		I	II		(eV 1 A 2)	(A)	Eq. (11)
G aA s	0.10	0.18	0.06	0.12	0.051	2.5	0.10
AlAs	0.29	0.27	0.19	0.23	0.060	2.0	0.13
ZnSe	0.36	0.68	0.24	0.46	0.041	1.8	0.40

the potential dierence obtained for A 1/G aAs and shown in Fig. 5.

In R ef. 26 we observed a som ewhat sim ilar behavior in the case of local dipoles inserted in the A 1/G aAs (100) junction. In the latter case, ab initio calculations were performed to determ ine the change in the lineup u induced by a dipole layer (i.e., two test charges + and

placed on two adjacent cation-anion planes) introduced at various distances x from the metal, within the sem iconductor. In this numerical experiment, the bare dipole perturbation is $u_b = 4 \ e^2 \ l$, where l is the separation between the charged planes, and from the computed u we could directly measure the elective dipole screening $e^{\rm dip} = u_b = u$ as a function of the dipole position x in the junction. This screening was found to be strongly inhomogeneous and to increase exponentially as the dipole was approaching the metal surface. This was attributed to the M IGS tails and their high polarizability in the interface region. We also proposed a model for $e^{\rm dip} = u$ which proved very accurate to describe the SBH changes u(x;) in the linear-response regime (i.e., to the rest order in).

$$_{e}^{\text{dip}}(x)$$
 ₁ + 4 $_{e}^{2}D_{s}(E_{F};x)_{s}$: (7)

Here D $_{\rm S}$ (E $_{\rm F}$; x) is the M IGS surface density of states at the Ferm ienergy and at the position x of the dipole, and $_{\rm S}$ is the decay length of the M IGS. The model Eq. (7) is also consistent with earlier M IGS-based model descriptions of Schottky barrier properties. 21 , 23 , 63

In order to predict, in general, the e ect of the surface term ination in M S junctions, we would like to develop a model for U that takes into account the inhom ogeneous nature of the electronic screening in the M IG S region and that is consistent with our previous results on the e ect of the dipole layers on the SBH. In particular, this model should be consistent with the fact that, in the linear-response regime (small j j), the sum of the SBH modications induced separately by two charges + and separated by a small distance l, U (x l=2;) and U (x+l=2;), respectively, must be equal to the SBH

modi cation induced by the corresponding dipole:

U (x
$$=2$$
;) U (x + $=2$;) = $\frac{4 e^2 1}{\stackrel{\text{dip}}{=} (x)}$: (8)

Expanding the left-hand side of Eq. (8) to the rst order in 1, we obtain the di erential equation:

$$\frac{\text{@ U}}{\text{@x}}(x;) = \frac{4 \text{ e}^2}{\text{dip}(x)}:$$
 (9)

With our expression for $_{\rm e}^{\rm dip}(x)$ in Eq. (7) and a surface density of states that decays exponentially, 64 D $_{\rm S}({\rm E_F};x)={\rm D_S(E_F;0)}\exp({\rm x=_S})$, the solution of Eq. (9) with the boundary condition U $({\rm x_0})=0$ is:

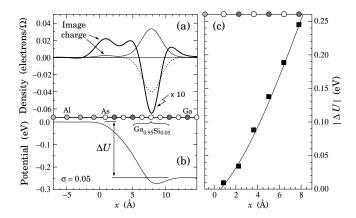
U (x;) = 4
$$e^2 - \frac{1}{1} \times x_0 \times \log \frac{\frac{\text{dip}}{e}(x_0)}{\frac{\text{dip}}{e}(x)}$$
; (10)

where x is the position of the surface charge. We note that for large values of x, we recover the classical lim it given by Eq (6), with $x_i = x_0 + \sum_s \log[\frac{dip}{e}(x_0)] = 1$.

W ith the exception of x_0 , all param eters necessary to evaluate U (x;) in Eq. (10) can be obtained straightforwardly from ab initio calculations performed either for the bulk sem iconductor (1) or for the unperturbed A 1/X junction (the M IG S-related parameters). In Table Π , we have reported our calculated values for the M IGS parameters D $_{\rm S}$ D $_{\rm S}$ (E $_{\rm F}$; 0) and $_{\rm S}$. These quantities were obtained from the calculated macroscopic average of the local density of states, N (E;x), as D $_{\rm S}$ = $_0^{\rm 1}$ N (E;x) dx and $_{\rm S}$ = $_0^{\rm 1}$ xN (E;x) dx, where the origin (x = 0) was taken as the midpoint between the last Al and the rst sem iconductor plane, and 1 indicates a position well inside the sem iconductor (the center of the sem iconductor slab in the supercell) where the M IGS vanish. As the values of D $_{\rm s}$ and $_{\rm s}$ are slightly di erent for the interfaces I and II, we reported in Table II the average between the values calculated for the two interfaces.65

In order to obtain an estim ate for x_0 , and also to test the model in Eq. (10), we have investigated ab initio the spatial dependence of U in the linear-response regime by introducing a small test surface charge = 0.05 in the A s-term inated A l/G aA s junction at dierent distances from the interface. This was done by replacing single layers of A s (G a) ions by virtual hA $s_{0.95}Si_{0.05}i$ (hG $a_{0.95}Si_{0.05}i$) anions (cations). As an example, we show in Fig. 6 the ab initio results for the charge density and potential induced by such a test charge on the sixth sem iconductor layer from the metal. The macroscopic averages of the ionic, electronic, and total charge densities are displayed in Fig. 6(a). We have used a G aussian

Iter function with full width at half maximum a=2 for the macroscopic average. This allows one, in particular, to distinguish the image charge contribution to the total charge density, close to the Alsurface. The macroscopic



(a) Macroscopic average of the electronic (thin solid line) and ionic (dotted line) charge densities induced by a plane of hG a_{0:95}Si_{0:05}i virtual ions in the As-term inated A 1/G aA s (100) junction. A Gaussian Iter function was used for the m acroscopic average. The thick solid line is the sum of the electronic and ionic densities, scaled by a factor of 10. (b) M acroscopic average of the corresponding induced total electrostatic potential. The resulting potential di erence U is also indicated. (c) Schottky barrier modi cation j U j (lled squares) obtained for a surface charge j j= 0:05 as a function of its position within the sem iconductor, in the Asterm in ated A 1/G aAs junction. The symbols give the results of the selfconsistent calculations. The solid line corresponds to the prediction of Eq. (10) with $x_0 = 0.6$ A. The atom ic positions are indicated using the same symbols for the atoms as in Fig. 1. The calculations were done in a 7 + 21 supercell.

average of the induced total electrostatic potential is displayed in Fig. 6(b). The corresponding potential dierence is $U=0.24~{\rm eV}$.

In Fig. 6(c) we have plotted the discontinuity j U j induced by the test charge as a function of its position in the A l/G aA s junction. W ith the theoretical dielectric constant of G aA s ($_1^{G \, aA \, s} = 12.4$) and the calculated values of D $_S$ and $_S$ given in Table II, the best to fEq. (10) to the data in Fig. 6(c) is obtained with $x_0=0.6 \, A$. The model results obtained from Eq. (10) using $x_0=0.6 \, A$ have been reported in Fig. 6(c), and compare well with the results of the self-consistent calculations as a function of the distance.

Having a reasonable estimate for x_0 we may now use Eq. (10) to obtain also an estimate for the dierence between the SBH's of the interfaces I and II. As we have seen before, this dierence may be evaluated as the potential change induced, to the rst order, by a surface charge = 1 (2) per unit-cell surface on the rst plane of the III-V (II-VI) semiconductor, i.e., at a position x = d=2 with d = 1:72 A (see Fig. 1). The resulting estimate $\frac{m}{p}$ of for the dierence p is thus

The results obtained with this model are displayed in Table II. To evaluate $p^{m \text{ od}}$, we have used the theo-

retical value of the sem iconductor dielectric constant $^{\rm X}_{\rm A}$ (X = GaAs, AlAs, and ZnSe), 66 the surface density of states Ds and MIGS decay length s given in Table II for the Al/GaAs, Al/AlAs and Al/ZnSe junctions, and $x_0=0.6$ A for all systems. The model results, in Table II, yield the correct trend and order of magnitude for the dierence between the SBH's. We note that decreasing x_0 increases $^{\rm mod}_{\rm p}$, but does not a ect the trend. The same conclusion applies when a possible change in x_0 , from GaAs to AlAs and to ZnSe, is taken into account by scaling the x_0 value obtained for GaAs with the ratio of the MIGS decay length, i.e., $^{\rm x}_{\rm s} = ^{\rm GaAs}_{\rm s} ^{\rm 67}$

A Ithough the present model approach provides a consistent picture of the elect of selected perturbations at MS interfaces, we would like to caution the reader that our model description applies to unrelaxed interfaces. In this connection it should be pointed out that a LRT model (based on dynamical elective charges) is available in the literature for quantitative predictions of the atom ic relaxation contribution to the SBH. ²⁷

V. CONCLUSION

U sing a rst-principle pseudopotential approach, we have investigated the Schottky barrier heights of abrupt lattice-m atched A I/G e, A I/G aAs, A I/A IAs, and A I/Z nSe (100) junctions, and their dependence on the sem iconductor chem ical composition and surface term ination. The sensitivity of the SBH to microscopic interface features reveals the limits of the currently accepted sem iem pirical models of Schottky barriers. Such model theories generally neglect the elects of the microscopic interfacial morphology. This is due in part to the complexity of the actual atom ic structure of most MS contacts, and also to the relatively limited information available on the atom ic-scale geometry of buried interfaces.

Based on our ab initio studies, we have derived models which explicitly include the e ects of the interface atom ic structure in the case of some prototype defectfree, lattice-m atched geom etries. These models retain, within speci cranges of applicability, the same accuracy as the ab initio calculations. They show, in particular, that while the variation of the average SBH of the abrupt, anion-and cation-term inated A 1/sem iconductor (100) interfaces can be explained mainly in terms of the bulk properties of the sem iconductors, the di erence between the barrier heights of the anion- and cation-term inated interfaces results from a microscopic dipole generated by the screened charge of the polar sem iconductor surface and its im age charge at the metal surface. Our atom icscale computations have also allowed us to show how the classical in age charge concept, valid for charges placed at large distances from the metal, can be extended to distances shorter than the decay length of the metalinduced-gap states.

A cknow ledgm ents

One of us (CB) acknow ledges support by the Sw iss National Science Foundation under G rant N 20-47065.96. The computations were performed at the CSCS in Manno.

APPEND IX A:MODEL FOR THE AVERAGE SBH OF THE ANION-AND CATION-TERM INATED INTERFACES

In order to explain the behavior of the average SBH $_{\rm p}$ with the sem iconductor composition, we have extended to MS contacts a linear-response theory approach commonly used to study band o sets at sem iconductor heterojunctions. The present analysis is also an extension to heterovalent sem iconductors of an approach outlined in Ref. 28 to model the Schottky-barrier changes with the alloy composition in Al/Gal $_{\rm A}$ A $_{\rm A}$ As junctions.

W e are interested in the average potential lineup $\overline{V}=\frac{1}{2}$ $V^{\rm I}+V^{\rm II}$, where $V^{\rm I(II)}$ is the potential lineup at the interface I (II), for which we want to establish the following model:

The rst term on the right-hand side of Eq. (A1) is the potential lineup at the reference (100) junction between Aland a group-IV (realor virtual) crystalhY i (e.g., the virtual crystalhX i or Ge), having a charge density close to the average charge density of the Al/X I and II junctions. The second term is the lineup at the non-polar (110) interface between the group-IV crystalhY i and the sem iconductor X . To derive Eq. (A1), we write the self-consistent electrostatic potential at the Al/X (100) I (II) junction as

$$V^{I(II)}(r) = V_0(r) + V_1^{I(II)}(r);$$
 (A2)

where V_0 (r) is the electrostatic potential at the A l/hY i (100) junction. The average lineup \overline{V} can be expressed, according to Eq. (A 2), as $\overline{V} = V_0 + V_1$, where V_0 V A \rightleftharpoons hY i (100)] and V_1 is the lineup of the potential

$$V_1(r) = \frac{1}{2} V_1^{I}(r) + V_1^{II}(r)$$
: (A3)

The potential $V_1^{\rm I\,(II)}$ is the self-consistent electrostatic potential induced in the A l/hY i (100) junction by the ionic substitutions, hY i! anion and hY i! cation, performed in the sem iconductor, which transform the A l/hY i system into the type-I (type-II) A l/X system. Thus $V_1^{\rm I}$ and $V_1^{\rm II}$ have long-range contributions associated with each heterovalent anion and cation substitution in the group-IV crystal. These long-range terms cancel out in the average in Eq. (A 3), since each anion (cation) substitution

in $V_1^{\,\mathrm{I}}$ is compensated by a cation (anion) substitution associated with the same site in $V_1^{\,\mathrm{II}}$. The average potential V_1 has therefore a well denned macroscopic average in the semiconductor, which is equal to V_1 , since V_1 (r) vanishes in the metal.

One may thus evaluate V_1 using a perturbative approach neglecting inter-site interactions in the ionic substitutions, because of the short-ranged nature of the potentials associated with each individual site. Within this approximation, V_1 is given by i) the superposition of the potentials induced by isolated anion and cation substitutions in the bulk crystal hY i plus ii) a correction due to the deviations from the bulk response for substitutions performed near the MS interface.

By construction, the potential lineup obtained from i) is orientation independent and equal to the potential lineup V 0 [Y i=X (110)] at the non-polar hY i=X (110) interface, built from a superposition of the same isolated charge-density responses on one side of the X (110) homojunction. Furthermore, previous ab initio and LRT studies of semiconductor heterojunctions have shown that the deviation of the lineup V (110) from the transitivity rule, and hence from V 0 (110), is typically less than 0.1 eV in IV-IV/III-V junctions, and of the order of 0.1 eV in IV-IV/III-V I junctions. 59,60 W e may therefore replace V 0 [Y i=X (110)] by V [Y i=X (110)] to obtain the contribution from i) to V1.

The correction to the lineup induced by ii) is given, to the rst order in the substitutions, by $V_{corr.} = i_i d_i$, where $d_i = 4 e^2 dx x n_i(x)$ is the dipole, and $n_i(x)$ the charge density, induced by the hYi! anion or hYi! cation layer substitution within the i^{th} atom ic plane from the interface in the Al/hY i junction. In practice, the dipoles di vanish beyond the 3rd to 4th atomic plane from the junction, and $V_{corr.}$ is generally of the order of 0.1 eV for isovalent substitutions. 28 Furtherm ore, when the Al/hX i junction is used as a reference system, V_{corr.} exactly vanishes, because the corrections are opposite in the I and II junctions and cancel out in the average leading to V_1 . The correction $V_{corr.}$ is therefore bound to be small (0:1 eV) when the reference system is an Al/hY i (100) junction with a density close to the average density of the A 1/X I and II junctions. We will thus neglect this correction, which leads V [hY i=X (110)], and hence to Eq. (A1).

In Table III, the average potential lineup at the A l/X (100) I and II interfaces is compared to the predictions of the model, Eq. (A1), obtained with hY i = hX i and with hY i = Ge. The agreement between $\overline{V}^{m \text{ od}}$ and the calculated \overline{V} is quite good, the discrepancy being 2% [8%] or less when the A l/hX i (100) A l/Ge (100)] junction is used as a reference system. Introducing the band energies in Eq. (A1), we obtain Eq. (4) [Eq. (5)] with hY i = hX i [hY i = Ge].

TABLE III: Comparison of the average potential lineup \overline{V} at the Al/X (100) I and II interfaces with the predictions of the model, \overline{V} V [A]=hY i (100)] + V [hY i=X (110)] [Eq. (A1)], using $hY i = hX i (V^{\text{mod}})$ and $hY i = Ge(\overline{V}^{\text{mod}})$. All numbers are in eV.

X		V		V m od	V		V mod ⁰
		Al/hX i (100)	hX i=X (110)		A 1/Ge (100)	Ge/X (110)	
G aA s	2:34	2:18	0:12	2:30	2:05	0:28	2:33
AlAs	2:01	1 : 97	0:01	1 : 98	2 : 05	+ 0:20	1:85
ZnSe	3:30	2:85	0:38	3:23	2:05	1:17	3:22

- E.H.Rhoderick and R.H.W illiams, Metal-Semiconductor Contacts (Clarendon Press, Oxford, 1988).
- ² L. J. Brillson, in Handbook on Semiconductors, Vol. 1, edited by P. T. Landsberg (North Holland, Amsterdam, 1992), p. 281.
- ³ R.T. Tung, in M aterials Interfaces, Atom ic-Level Structures and Properties, edited by D. W olf and S.Y ip (Chapman & Hall, London, 1992), p. 550.
- 4 G.Margaritondo, Rep.Prog.Phys.62,765 (1999).
- ⁵ S.De Franceschi, F.Beltram, C.M arinelli, L.Sorba, M. Lazzarino, B.H.M uller, and A. Franciosi, Appl. Phys. Lett. 72, 1996 (1998).
- ⁶ L. Sorba, S. Y ildirim, M. Lazzarino, A. Franciosi, D. Chiola, and F. Beltram, Appl. Phys. Lett. 69, 1927 (1996); G. Gigli, M. Lomascolo, M. De Vittorio, R. Cingolani, A. Cola, F. Quaranta, L. Sorba, B. Mueller, and A. Franciosi, Appl. Phys. Lett. 73, 259 (1998).
- T.dell'Orto, J.A lm eida, A. Terrasi, M. Marsi, C. Coluzza, G. Margaritondo, and P. Perfetti, Phys. Rev. B 50, 18189 (1994); J. A lm eida, C. Coluzza, T. dell'Orto, G. Margaritondo, A. Terrasi, and J. Ivanco, J. Appl. Phys. 81, 292 (1997).
- M. Cantile, L. Sorba, S. Yildirim, P. Faraci, G. Biasiol, A. Franciosi, T. J. Miller, and M. I. Nathan, Appl. Phys. Lett. 64, 988 (1994); M. Cantile, L. Sorba, P. Faraci, S. Yildirim, G. Biasiol, G. Bratina, A. Franciosi, T. J. Miller, M. I. Nathan, and L. Tapfer, J. Vac. Sci. Technol. B 12, 2653 (1994).
- ⁹ K. Koyanagi, S. Kasai, and H. Hasegawa, Jpn. J. Appl. Phys. 32, 502 (1993).
- J.C.Costa, F.W illiam son, T.J.M iller, K.Beyzavi, M. I.N athan, D.S.L.M ui, S.Strite, and H.M orkoc, Appl. Phys. Lett. 58, 382 (1991); J.C.Costa, T.J.M iller, F. W illiam son, and M.I.N athan, J.Appl. Phys. 70, 2173 (1991); T.J.M iller and M.I.N athan, Appl. Phys. Lett. 61, 2332 (1992).
- M. Lazzarino, G. Scarel, S. Rubini, G. Bratina, L. Sorba, A. Franciosi, C. Berthod, N. Binggeli, and A. Baldereschi, Phys. Rev. B 57, R 9431 (1998).
- W. Chen, A. Kahn, P. Soukiassian, P. S. Mangat, J. Gaines, C. Ponzoni, and D. Olego, J. Vac. Sci. Technol. B 12, 2639 (1994).
- See, e.g., A. Barinov, L. Casalis, L. Gregoratti, and M. Kiskinova, Phys. Rev. B 63, 085308 (2001); S. Picozzi, A. Continenza, G. Satta, S. Massidda, and A. J. Freeman, Phys. Rev. B 61, 16736 (2000).
- 14 Electronic Structure of Metal-Semiconductor Contacts,

- edited by W . M onch (Jaca, M ilano, 1990).
- ¹⁵ V.Heine, Phys. Rev. 138, A 1689 (1965).
- ¹⁶ J. Terso , Phys. Rev. Lett. 52, 465 (1984).
- ¹⁷ F.Flores and C.Tejedor, J.Phys.C:Solid State Phys. 20, 145 (1987); F.Guinea, J. Sanchez-Dehesa, and F.Flores, J.Phys.C 16, 6499 (1983).
- 18 W .Spicer, Sem icond.and Sem im etals, 38, 449 (1993).
- ¹⁹ J.M.Woodalland J.L.Freeouf, J.Vac.Sci.Technol. 21, 574 (1982).
- ²⁰ G. M argaritondo and P. Perfetti, in Heterojunction band discontinuities, edited by F. Capasso and G. M argaritondo (N orth-Holland, Am sterdam, 1987), p. 59.
- ²¹ S.G.Louie, J.R.Chelikowsky, and M.L.Cohen, Phys. Rev. B 15, 2154 (1977).
- J.P.Sullivan, R.T.Tung, D.J.Eaglesham, F.Schrey, and W.R.Graham, J.Vac.Sci.Technol. B 11, 1564 (1993).
- ²³ S.B. Zhang, M.L.Cohen, and S.G.Louie, Phys. Rev. B 32, 3955 (1985).
- ²⁴ R.G.Dandrea and C.B.Duke, J.Vac.Sci. Technol. B 11, 1553 (1993).
- R. J. Needs, J. P. A. Charlesworth, and R. Godby, Europhys. Lett. 25, 31 (1994); J. P. A. Charlesworth, R. Godby, R. J. Needs, and L. J. Sham, Mater. Sci. Eng. B 14, 262 (1992).
- ²⁶ C. Berthod, N. Binggeli, and A. Baldereschi, Europhys. Lett. 36, 67 (1996); C. Berthod, J. Bardi, N. Binggeli, and A. Baldereschi, J. Vac. Sci. Technol. B 14, 3000 (1996).
- ²⁷ A.Ruini, R.Resta, and S.Baroni, Phys.Rev.B 56, 14921 (1997).
- ²⁸ J. Bardi, N. Binggeli, and A. Baldereschi, Phys. Rev. B 59, 8054 (1999).
- ²⁹ W .E.Pickett, Comp.Phys.Rep.9,117 (1989).
- ³⁰ N. Troullier and J. L. Martins, Phys. Rev. B 43, 1993 (1991).
- The Ga 3d and Zn 3d electrons were treated as frozen core orbitals. It has been shown that including the Ga 3d orbitals in the valence shell amounts to including a rigid (sem iconductor bulklike) correction of 0:1 eV on the Al/GaAsSBH, which we neglect here.
- ³² L. K leinm an and D. M. Bylander, Phys. Rev. Lett. 48, 1425 (1982).
- ³³ D.M.Ceperley and B.J.Alder, Phys. Rev. Lett. 45, 566 (1980).
- ³⁴ H. J. Monkhorst and J. D. Pack, Phys. Rev. B 13, 5188 (1976).
- 35 C. Berthod, N. Binggeli, and A. Baldereschi, Phys. Rev. B 57, 9757 (1998).

- $^{36}\,$ C . Berthod, N . B inggeli, and A . Baldereschi, unpublished.
- ³⁷ R.M.D reizler and E.K.U.G ross, Density Functional Theory (Springer-Verlag, Berlin, 1990).
- 38 C.J. Fall, N. Binggeli, and A. Baldereschi, Phys. Rev. B 58, R7544 (1998).
- ³⁹ X. Zhu and S.G. Louie, Phys. Rev. B 43, 14142 (1991).
- The GW calculations for Ge and AlAs in Ref. 39 have been performed using the von Barth-Hedin form of the exchange-correlation potential. The quasiparticle correction to the LDA bandgap is more or less independent of the choice of the exchange-correlation potential, but the distribution of this correction between the valence and conduction bands depends on this choice (X.Blase, private communication). Since we employ the Ceperley-Alder exchange potential in our calculations, we prefer to use the correction of Ref. 25 for GaAs, based on this potential, and only the dierence between the Ge, AlAs, and GaAs corrections of Ref. 39.
- O. Zakharov, A. Rubio, X. Blase, M. L. Cohen, and S.G. Louie, Phys. Rev. B 50, 10780 (1994).
- 42 Landolt-Bornstein, Numerical Data and Functional Relationships in Science and Technology (Springer, New York, 1982).
- 43 In Ref. 35 the many-body and spin-orbit correction used for the A 1/G aA s SBH was 0.21 eV , and not 0.11 eV as indicated by m istake in the caption of Table I.
- ⁴⁴ L. J. Brillson, I. M. V itom irov, A. Raisanen, S. Chang, R. E. V iturro, P. D. K irchner, G. D. Pettit, and J. M. W oodall, Appl. Surf. Sci. 65, 667 (1993).
- ⁴⁵ A .T hanailakis and D .C .N orthrop, Solid-State E lectronics 16, 1383 (1973).
- ⁴⁶ S.M. Sze, Physics of Sem iconductor Devices (John W iley & Sons, New York, 1981).
- ⁴⁷ N.M. Johnson, T.J. Magee, and J. Peng, J. Vac. Sci. Technol 13, 838 (1976).
- ⁴⁸ A.Y.Cho and P.D.Demier, J.Appl.Phys. 49(6), 3328 (1978).
- $^{\rm 49}$ W .I.W ang, J.Vac.Sci.Technol.B 1,574 (1983).
- ⁵⁰ C. Barret and J. Massies, J. Vac. Sci. Technol. B 1, 819 (1983).
- 51 S.J.Eglash, M.D.W illiam s, P.H.M ahowald, N.Newman, I.Lindau, and W.E.Spicer, J.Vac.Sci.Technol.B 2, 481 (1984)
- ⁵² J.R.W aldrop, Appl.Phys.Lett.47, 1301 (1985).
- ⁵³ M.M. issous, E.H.Rhoderick, and K.E.Singer, J.Appl. Phys. 60, 2439 (1986).
- 54 S.J.Eglash, N.Newman, S.Pan, D.Mo, K.Shenai, W. E.Spicer, F.A.Ponce, and D.M.Collins, J.Appl.Phys. 61,5159 (1987).
- M. M issous, W. S. Truscott, and K. E. Singer, J. Appl. Phys. 68, 2239 (1990).
- ⁵⁶ A. Bosacchi, S. Franchi, E. Gombia, R. Mosca, F. Fantini, R. Menozzi, and S. Naccarella, Electron. Lett. 30, 820 (1994).
- ⁵⁷ M. Vos, F. Xu, Steven G. Anderson, J. H. Weaver, and H. Cheng, Phys. Rev. B 39, 10744 (1989).
- Alcan be classi ed as a reactive m etal [see, e.g., C.I.W u, A.Kahn, A.E.W ickenden, D.Koleske, and R.L.Henry, J. Appl.Phys.89, 425 (2001)]. In the case of Al/GaAs (100),

- in particular, a Ga-Alexchange reaction yielding excess GaAlAs at the interface is known to take place [S.A. Chambers, Phys. Rev. B 39, 12664 (1989)]. It should be noted, however, that if the transitivity rule holds at the Al/GaAs, Al/GaAlAs, and GaAs/GaAlAs interfaces (see Ref. 28 for a discussion), the presence of a GaAlAs interlayer should have no elect on the Al/GaAs Schottky barrier.
- 59 S.Baroni, R.Resta, A.Baldereschi, and M.Peressi, Proc. NATO Advanced Research Workshop on Spectroscopy of Semiconductor Microstructures, edited by G.Fasol et al. (Plenum, New York, 1989), p.251; A.Baldereschi, M.Peressi, S.Baroni, and R.Resta, in Proceedings of the International School of Physics \Enrico Fermil (Course CXVII, Varenna, 1991): Semiconductor Superlattices and Interfaces, edited by L.Miglio and A.Stella (Academic, New York, 1993), p.59.
- M. Peressi, N. Binggeli, and A. Baldereschi, J. Phys. D: Appl. Phys. 31, 1273 (1998).
- ⁶¹ A .Franciosi and C .G .V an de W alle, Surface Science Reports 25, 1 (1996).
- It should be noted that $n_a(r) [n_c(r)]$ in Eq. (3) is neutral, and carries no dipole nor quadrupole (except for the second spherical moment of the charge given by Eq. (3)), because of the tetrahedral T_d symmetry of the impurity site (see Ref. 59 or 60). The integral in Eq. (3) is therefore well dened; in particular, the result does not depend on the choice of the origin.
- ⁶³ A.M. Cowley and S.M. Sze, J. Appl. Phys. 36, 3212 (1965).
- Justi cation for the general use of an exponential decay of the M IGS can be found, e.g., in A. Ruini, ph D these, SISSA (1997), http://www.sissa.it/cm/phd.php; see, e.g., Fig. 7.1 and 7.10 therein.
- We note that a som ewhat larger value of $_{\rm S}$ (3.2 A) was used in Ref. 26 to model the e ect of Si interlayers on the A 1/G aA s SBH . In the latter study, $_{\rm S}$ was not calculated from rst principles, but taken as a parameter value giving good general agreement with the SBH modi cations induced in a junction containing up to 2 Si monolayers. The estimated uncertainty on the present $_{\rm S}$ calculated for the unperturbed A 1/X junction is about 0.2 A . This uncertainty takes into account deviations of N (E $_{\rm F}$; x) from an ideal exponential function, which give rise to some variations of $_{\rm S}$ with x. Such a change in $_{\rm S}$, however, has a small in uence on the model results in Fig. 6 (c) and Table II (12% at most).
- The theoretical macroscopic dielectric constants, $_1$, have been calculated using the capacitor model of M. Peressi et al., Phys. Rev. B 43, 7347 (1991). We nd $_1^{G \text{ aAs}} = 12.4$, $_1^{A \text{ lAs}} = 9.1$, and $_1^{Z \text{ nSe}} = 6.2$; the experimental values are 10.9, 8.2, and 6.3 for G aAs, A lAs, and ZnSe, respectively.
- 67 U sing $x_0 = 0.5$ A in the model, Eq. (11), yields m od = 0.14, 0.17, and 0.55 eV for GaAs, AlAs, and ZnSe, respectively. Scaling, instead, the x_0 value obtained for GaAs (0.6 A) with the ratio $^{x}_{s} = ^{g}_{s}$ and $^{a}_{s}$, the corresponding results are 0.10, 0.18, and 0.65 eV, respectively. In both cases, the model results give satisfactory agreement with the values calculated ab in itio.